

AMENDMENT

Kindly amend the application, without prejudice, without admission, without surrender of subject matter, and without any intention of creating any estoppel as to equivalents as follows:

IN THE CLAIMS:

Please amend claim 1, without prejudice, without admission, without surrender of subject matter, and without any intention of creating any estoppel as to equivalents, to read as follows:

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1. (Amended) A method of depositing in situ a solid film on a substrate, comprising the steps of:
- providing a substrate;
 - heating the substrate such as to provide for deposition of a solid film;
 - providing a nozzle unit for delivering an aerosol to the substrate, the nozzle unit including at least one outlet through which a directed flow of the aerosol is delivered and at least one electrode;
 - generating an aerosol comprising droplets of a material solution upstream of the nozzle unit;
 - providing a flow of the aerosol through the nozzle unit so as to deliver a directed flow of the aerosol from the at least one outlet; and
 - generating an electric field between the substrate and the at least one electrode such that the aerosol droplets are charged with a positive or negative charge and the directed aerosol flow is attracted towards the substrate.
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